

VIA FACSIMILE NO. (703) 872-9310

PATENT
MIC04 P-106

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner : George A. Goudreau
 Group : 1763
 Confirmation No.: 4253
 Applicant : Imad Mahawili, PhD
 Serial No. : 09/488,309
 Filed : January 20, 2000
 For : REACTOR WITH REMOTE PLASMA SYSTEM AND
 METHOD OF PROCESSING A SEMICONDUCTOR
 SUBSTRATE

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OFFICIAL

Commissioner for Patents
 P.O. Box 1450
 Alexandria VA 22313-1450

Date of this Paper: December 17, 2003.

Dear Sir:

PETITION AND FEE FOR
EXTENSION OF TIME (37 C.F.R. 1.136(a))

1. This is a petition for an extension of time to respond to the Office Action mailed July 17, 2003, for a period of two months.
2. Applicant is:

 a small entityverified statement attached
verified statement filed x other than small entity

| 3. Extension (months) | Fee for other than small entity | Fee for small entity |
|--------------------------|------------------------------------|-------------------------|
| one month | \$110.00 | \$55.00 |
| X two months | \$420.00 | \$210.00 |
| three months | \$950.00 | \$475.00 |

4. An amendment:

 x is filed herewith has been filed

5. Fee Payment:

 x Please charge the amount of \$420 and any additional fees required or credit any excess fee paid to Deposit Account No. 22-0190. A duplicate of this Petition is attached.

VAN DYKE, GARDNER, LINN & BURKHART, LLP


 Catherine S. Collins
 Registration No. 37 599
 2851 Charlevoix Drive, S.E.
 P.O. Box 888695
 Grand Rapids, MI 49588-8695
 (616) 975-5500

CSC:lmsc